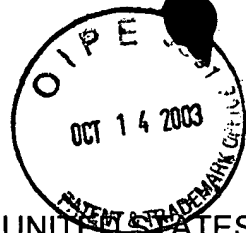
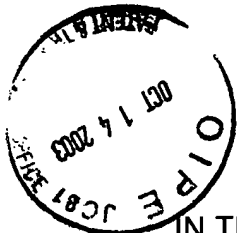


2824



Attorney Docket No. 0756-2417

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Shunpei YAMAZAKI et al.
Serial No. 10/034,498
Filed: January 3, 2002
For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2824
) Examiner: B. Smith

) CERTIFICATE OF MAILING
) I hereby certify that this correspondence is being
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Adrian M. Stampen

7#/
Election
10/21/03
DBm

RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the election requirement in the Office Action of September 9, 2003, Applicant hereby elects without traverse Species 3 directed to irradiating a first surface from a slant direction. Claims 3 and 30-39 read upon the elected species and claim 1 is generic.

Examination on the merits is requested.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

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